

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Tien-Chen Hu

Group Art Unit: 3723

Serial No.: 09/820,107

Examiner: Shantese L. McDonald

Filed:

March 28, 2001

In Response to Office Action

Dated: Nov. 4, 2003

For:

Linear Chemical Mechanical Polishing Apparatus Equipped with Programmable Pneumatic Support

Platen and Method of Using

Attorney Docket No.: 67,200-364

## Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Kathy Dixon

Date: Feb. 4, 2004

RECEIVED FEB 1 1 2004

RESPONSE TO OFFICE ACTION

TECHNOLOGY CENTER R3700

Commissioner for Patents Alexandria, VA 22313-1450

Dear Sir:

In response to an Office Action mailed Nov. 4, 2003, please enter the following amendments and consider the following remarks.